

UNITED STATES PATENT AND TRADEMARK OFFICE

Bib Data Sheet

CONFIRMATION NO. 2965

SERIAL NUMBER 10/519,401	FILING OR 371(c) DATE 01/04/2005 RULE	CLASS 134	GROUP ART	ROUP ART UNIT		ATTORNEY DOCKET NO. 264189US3PCT	
Hiroshi Shinriki, Yamanashi, JAPAN; Kazuya Dobashi, Yamanashi, JAPAN; Mikio Suzuki, Yamanashi, JAPAN; Takashi Magara, Yamanashi, JAPAN; ***********************************							
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged Examiner's Signature ADDRESS 22850		JAPAN	SHEETS DRAWING 19	AWING CLAI		INDEPENDENT CLAIMS 5	
TITLE Method of cleaning substrate-processing device and substrate-processing device							
FILING FEE FEES RECEIVED No 2100 No	S: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following:			☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			